Development of the Next Generation Microshutter Arrays for Space Telescope Applications


NASA Goddard Space Flight Center

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Next Generation Microshutter Arrays (NGMSA) - programmable field masks

- Microshutter arrays are programmable field selector masks for optical spectroscopy based on MEMS technology.
- The original device was developed as a sub-assembly instrument for JWST (James Webb Space Telescope: Random access addressing of the individual pixels; High contrast optical blocking > 1e4; and long life time for the operation of 20,000 cycles or more.
- NGMSA: electrostatic actuation; JWST MSA: magnetic actuation

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Microshutter cell, array, and assembly design

- **Fully electrostatic actuation**
  - Higher voltage electrical insulation:
    - ALD aluminum oxide
  - Thinner microshutter blades

- **Modifications of arrays and assembly**
  - Improved antistiction
  - Simplified electronics design
  - Various array sizes to meet instrument requirements
  - Arrays are packaged with ceramic substrate instead of Si substrate

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Fabrication development

• Left: A SEM image of the front side image of the MSA. On the microshutters, the patterned microshutter blade, torsion bar and strips of molybdenum nitride are shown.

• Right: A SEM image of the MSA with the light shields that prevent light passing through the perimeters around the microshutters.

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Shutter electrodes and ALD aluminum oxide insulation

• The ALD (atomic layer deposition) aluminum oxide process developed for the NGMSA shows required level of breakdown voltage exceeding 100V. This ALD insulation improvement was critical over the JWST enabling the NGMSA electrostatic actuation.

Front side of shutter: column electrodes

Backside of shutter: row electrodes

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Antistiction measures

- Dimples/bumps on light shields are to prevent shutters stuck on light shields when shutters close.
- Ribs on back walls are to prevent shutters from getting stuck when shutters opened and latched.

Heptadecafluoro-1,1,2,2-tetrahydrodecyltrichlorosilane (FDTS) coated on entire NGMSA assemblies to prevent stiction due to water molecules.

Optical images of water drops obtained before and after anti-stiction coating is applied.

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Electrostatic operation: actuation, latch and addressing

- Left figure: Reconfigurable 2-D addressing electrostatic actuation
- Middle figure: an illustration of how the shutters are individually actuated and addressed by applying a pulsed voltage to the front electrodes (left) and a DC voltage to back electrodes (top). Only the shutters with voltage difference between the front and back electrodes latch open by rotating 90° about their torsion bars
- Right figure: an illustration of the row and column voltages applied to open, latch, hold, and close a single shutter using DC plus pulse actuation.

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Microshutters addressed

Image sequences demonstrating shutter operation. The opened shutter at the intersection of the applied DC-bias and pulse signals will remain latched as a DC-bias is applied at the corresponding rows.

i) -25V DC bias applied at columns one and three
ii) 100V pulse at rows one and three
iii) DC bias removed at column three
iv) DC bias moved from column one.

2-D addressing images made on a NGMSA shutter array using DC pulsed actuation mechanism. The demonstration was performed in vacuum using a 100V DC, 200 μs pulse to open selected shutters.

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Current modifications

- Simulation results of actuation torque between the original rectangle and new keystone-shaped shutter. For 100-volt actuation voltage, the minimum actuation torque (20 degree) of the new design increases by a factor of 3.
- The simulation results provide a potential to reduce actuation voltages with small dimension change of shutter blades.

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Microshutter arrays in several formats have been produced: pilot array -128 x 64 (left), JWST- 365 x 171 (center) and current development – 840 x 420 (right).

NGMSA 840x420 and JWST arrays size comparison: front (left) and back (right) side of the device wafers.

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NGMSA arrays integrated in Big-θ assembly for NG-FORTIS flight mission

Fully integrated 128x64 NGMSA array attached to a Big-θ assembly on NG-FORTIS telescope

Sounding Rocket carrying NG-FORTIS telescope before launch.

NG-FORTIS flight mission was successfully executed on Oct 27, 2019, NGMSA array functioned as required.

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NGMSA modularity for future large format space missions

- The microshutter baseplate is supported on the mosaic plate using a 3-vane kinematic mount.
- The mosaic plate is made of the instrument structural material, and the baseplate most favorite material is alumina ceramic.
- The mount provides precision position stability over a range of temperatures and provides stress-free mounting of the baseplate.
- Electrical interconnects on the board will set a limit on the width of the baseplate.
- This mosaic concept is for a 2 x 3 array of microshutters modules as proposed in a study for LUVOIR, a future space telescope candidate.

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Summary

• Next Generation Microshutter Arrays have been developed for electrostatic actuation.

• NGMSA arrays are being fabricated with modifications for simplified design, and more reliable performance.

• Functions of 128x64 NGMSA array assemblies have been demonstrated in a sounding rocket space mission: NG-FORTIS telescope that was launched to space successfully in Oct. 2019.

• 840x420 large NGMSA arrays are being developed for future large format deep space telescopes.

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